

INFORMATION DISCLOSURE CITATION

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Applicant	Kiminori WATANABE et al.		
Filing Date	Herewith	Group:	2815

U.S. PATENT DOCUMENTS							
Examiner Initial*		Document Number	Issue Date	Name	Class	Sub Class	Filing Date If Appropriate
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OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)							
M	J.A. Appels, et al., "High Voltage Thin Layer Devices (Resurf Devices), Philips Research Laboratories, Proc. IEDM, pp. 238-241, (1979).						

Examiner	<i>M</i>	Date Considered	<i>3/7/05</i>
*Examiner:	Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.		
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